

Form PTO-1449

Document Number (Optional)

Application Number

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Applicant

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Group Art Unit

INFORMATION DISCLOSURE CITATION
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(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

EXAMINER TO PROCEED TO	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
9V	6441487	8/27/02	Elenius et al.	257	738	10/20/97
9V	6429530	8/6/02	Chen	257	778	11/2/98
9V	6344234	2/5/02	Dalal et al.	427	96	6/7/95

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
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OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)

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